

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,138,984 B1
APPLICATION NO. : 09/875401
DATED : November 21, 2006
INVENTOR(S) : Mark W. Miles

Page 1 of 2

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On Page 4, in Column 1, under U.S. Patent Documents, line 15, delete
“Adelman” and insert -- Adelmann --, therefor.

On Page 4, in Column 1, under Foreign Patent Documents, line 17, after
“WO 03/073151” insert -- A1 --.

On Page 4, in Column 1, under Other Publications, line 16, delete “internet:”
and insert -- Internet: --, therefor.

On Page 4, in Column 2, under Other Publications, line 21, delete
“Microstructures” and insert -- Microstructure --, therefor.

On Page 4, in Column 2, under Other Publications, line 24, delete
“date unknown.” and insert -- (date unknown). --, therefor.

On Page 4, in Column 2, under Other Publications, line 49, delete “Capactions”
and insert -- Capacitors --, therefor.

On Page 5, in Column 1, under Other Publications, line 7, delete “Si02,” and
insert -- SiO₂ --, therefor.

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On Page 5, in Column 1, under Other Publications, line 12, delete

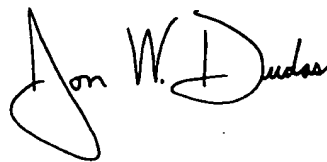
“Michromachining” and insert -- Micromachining --, therefor.

In column 6, line 2, in Claim 8, delete “front surface” and insert

-- front-surface --, therefor.

Signed and Sealed this

Fifth Day of August, 2008

A handwritten signature in black ink, appearing to read "Jon W. Dudas". The signature is stylized with a large, looped initial "J" and a cursive "Dudas".

JON W. DUDAS
Director of the United States Patent and Trademark Office